



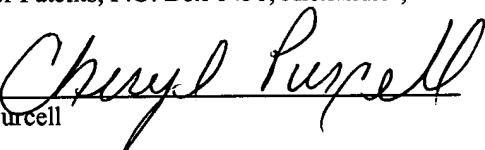
DOCKET NO: VSEA 28-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Steven R. Walther et al.
Serial No: 10/005,613
Confirmation No: 9731
Filed: October 26, 2001
For: HYBRID SCANNING SYSTEM AND METHODS FOR ION
IMPLANTATION
Examiner: Rodney Glen McDonald
Art Unit: 1753

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 7 day of August, 2004.



Cheryl Purcell

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Petition for Extension of Time

A three-month extension of time to August 4, 2004 is requested for response to the Examiner's Final Office Action of February 4, 2004.

The extension fee of \$950.00 may be charged to deposit account No. 50-0896. If the amount is insufficient, please charge deposit account No. 50-0896. A duplicate of this Petition is enclosed.

Respectfully submitted,
Steven R. Walther et al., Applicants

By: 

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